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Title of Invention	METHODS FOR HIGH-PRECISION GAP AND ORIENTATION SENSING BETWEEN A TRANSPARENT TEMPLATE AND SUBSTRATE FOR IMPRINT LITHOGRAPHY		
Application Number :	09/920341		
Date :	2001-08-01		
First Named Applicant:	Choi Byung J.		
Confirmation Number:	4146		
Attorney Docket Number:	PA17-07V06		
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